

|  |                             |                    |
|--|-----------------------------|--------------------|
| Form PTO-1449  | Document Number (Specified) | Application Number |
| INFORMATION DISCLOSURE CITATION<br>IN AN APPLICATION | TSMC-02-1147                | 10/719,721         |
| (Use several sheets if necessary)                    | Applicant                   | Wen-Chi Chien      |
|  | Filing Date                 | Group Art Unit     |
|  | 11/21/03                    |                    |



U. S. PATENT DOCUMENTS

## FOREIGN PATENT DOCUMENTS

|  | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION |    |
|--|-----------------|------|---------|-------|----------|-------------|----|
|  |                 |      |         |       |          | YES         | NO |
|  |                 |      |         |       |          |             |    |
|  |                 |      |         |       |          |             |    |
|  |                 |      |         |       |          |             |    |
|  |                 |      |         |       |          |             |    |
|  |                 |      |         |       |          |             |    |

**OTHER DOCUMENTS** (including Author, Title, Date, Portion or Pages, Etc.)

M - "Understanding the Fundamentals of Kanban and Continuous Pull Systems Using Simulation," Marek, et al., Proceedings of the 2001 Winter Simulation Conf. pp. 921-929, found on the web site [www.informs.cs.org](http://www.informs.cs.org), 6/12/03.

СИМЕНС

DATE CONSIDERED

<sup>ED</sup> 3/17/06

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.